

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Ilya Karpov et al.

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For: Fabricating Deeper and Shallower  
Trenches in Semiconductor Structures

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Atty Docket: ITL.0835D1US  
P14730D

Mail Stop Patent Application

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT**

Sir:

Please amend the above-referenced application.